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APPLICANTS

Seung Cheol Lee, Ichon-Shi, KOREA, REPUBLIC OF;

Sang Wook Park, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

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Verified and Acknowledged Examiner's Signature Initials	KOREA, REPUBLIC OF	4	5	1

ADDRESS

04743
 MARSHALL, GERSTEIN & BORUN LLP
 6300 SEARS TOWER
 233 S. WACKER DRIVE
 CHICAGO , IL
 60606

TITLE

Method of forming tunnel oxide film in semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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